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10/10/02

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On: OCTOBER 4, 2002

By: 

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by
an enclosed check, may be charged on Deposit Acct.
No. 50-1290.

ATTORNEY DOCKET NO. NECK 17.552IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner: Timothy J. Sutton

Group Art Unit: 2813

RECEIVED
OCT 10 2002
TECHNOLOGY CENTER 2800

Assistant Commissioner for Patents
Washington, D.C. 20231

10/08/2002 HVUONG1 00000053 501290 09614286

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PETITION FOR EXTENSION OF TIME

S I R :

Applicant requests that the time for taking action in this case be extended pursuant to 37
CFR 1.136(a) for:

☐ one month☐ three months☒ two months☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$400.00.

☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ **Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

☐ Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

☐ has been filed

☐ is enclosed

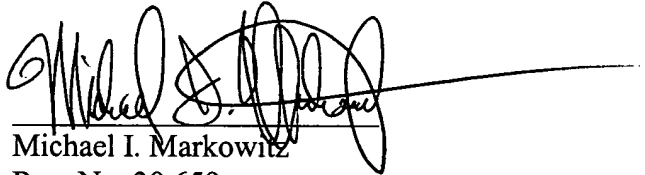
Also enclosed is a:

☒ **Response to Official Action**

☐ Notice of Appeal

☐ Appeal Brief

Respectfully submitted,



Michael I. Markowitz
Reg. No. 30,659

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